



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

5 Applicant(s): Babich et al.  
Docket No.: YOR920030174US1  
Serial No.: 10/634,667  
Filed: August 5, 2003  
10 Group: 1752  
Examiner: A.C. Walke  
  
Title: Lithographic Antireflective Hardmask Compositions and Uses Thereof

I hereby certify that this paper is being deposited on this date with the U.S. Postal Service as first class mail addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Signature: Susan F. [Signature] Date: November 23, 2005

RESPONSE TO OFFICE ACTION

20 Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
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Sir:

In response to the outstanding Office Action, dated July 26, 2005, Applicants submit the  
30 following remarks.